Electronic noise measurements as a tool for characterisation of physical processes in semiconductor heterostructures Jacek Przybytek Institute of Experimental Physics, Warsaw University, Poland



Abstract:

Nowadays semiconductor heterostructures and devices become smaller and smaller. Therefore electronic transport properties of small electronic systems are substantially influenced by stochastic processes related to thermal agitation and quantum transitions of electrons and quasiparticles. The purpose of this presentation is to familiarize our semiconductor community with electronic noise measurements as a method for characterisation of physical processes in

semiconductor heterostructures "The noise is the signal" (R. Landauer) and - moreover - there is a signal in the noise, which is absent in time-avereged value of the physical quantity; especially for

nonequilibrium processes like e.g. electron transport through tunneling barrier.

Fluctuations (noise):

spontaneous, random (stochastic) deviations from the time-average of the physical quantity. They manifest a thermal agitation and quantum (discrete) nature of matter (charge, spin, etc...).

Power SpectrumDensity (PSD) of fluctuations

 $\widetilde{X}(\omega) = \int x(t)e^{-i\omega t}dt$ Fourier transform of the measured signal x(t), units: V/Hz, A/Hz, etc.

 $x(t) = \frac{1}{2\pi} \int \widetilde{X}(\omega) e^{i\omega t} d\omega \quad \text{real signal } x(t), \text{ units: V, A, etc.}$

 $W = \int x^2(t) dt = \frac{1}{2\pi} \int |\widetilde{X}(\omega)|^2 d\omega \quad \text{total ,,energy" of the signal } x(t); \text{ units V}^2/\text{Hz, A}^2/\text{Hz, }$

 $S_{xx}(\omega) = \frac{1}{2\pi} \lim_{T \to \infty} \frac{\left| \widetilde{X}(\omega) \right|^2}{2T}$ Power Spectrum Density (PSD), units: V²/Hz, A²/Hz, etc or RMS: $\frac{V}{\sqrt{Hz}}, \frac{A}{\sqrt{Hz}}$ where 2*T* is the time interval for Fourier transform, where the signal is not equal zero. $P = \langle x^2(t) \rangle = \lim_{T \to \infty} \frac{1}{2T} \int_{-\infty}^{T} x^2(t) dt = \int_{-\infty}^{\infty} \lim_{T \to \infty} \frac{1}{2\pi} \frac{\left| \widetilde{X}(\omega) \right|^2}{2T} d\omega = \int_{-\infty}^{\infty} S_{xx}(\omega) d\omega \quad \text{total ,,power'' of the signal}$

Origin: thermal movement of electrons

PSD: S(*f*)=4*kTR* (V²/Hz), white noise for f < kT/h

Observation



J.B. Johnson *Phys. Rev.* **32**, 97 (1928) taken from G.H. Wannier, *Statistical Physics*, Dover Publications, Inc., New York, 1966

Fluctuation - Dissipation Theorem (Nyquist 1928, Callen, Welton 1951)

$$S_{I}^{\text{int}}(f) = 4k_{B}T \operatorname{Re} Z^{-1}(f)$$
$$S_{U}^{\text{int}}(f) = 4k_{B}T \operatorname{Re} Z(f)$$

The spectral density of fluctuations in the system in equilibruim and the respose of the physical system to the small external perturbation are governed by the same kinetic processes. Basing on F-D Theorem one can independently determine (using noise measurements) the kinetic coefficients (e.g. conductivity).

sensors based on GaAlAs/InGaAs/GaAs pseudomorfic heterostructure with 2DEG







1D array, $W = 4 \mu m$ Contact pair $n^{\circ}5$, T = 80 K Contact pair n°1, T=76 K 10^1 10^2 10^3 10^4 10^5 0.1 - 1Frequency (Hz)

biasing current of 200 μ A. Dots are Hall output at T=80 K (SVlor1=1.5×10-13 V2/Hz, SVlor2=10-15 V2/Hz, fc1 = 1 Hz,

noise of the preamplifier.

output noise spectrum density



• The predominant source of LF-noise in GaAs based quantum well Hall effect sensors depends on the operating temperature spectrum, with an intermediate form between lorentzian and pure 1/f form, is due to the continuous distribution of the energy of the interface states.

• For larger devices, the LF low-temperature noise appears as a true 1/f noise, whereas for micrometer size devices it resolves into discrete RTS signals originating in discrete fluctuators. In Hall crosses with an arm width of 4 µm, we find at 77K less than 1 fluctuator per each decade of the time constant. As noise at 1 Hz than much larger $60 \times 60 \ \mu m^2$ sensors.

1.J. Przybytek, V. Mosser, Y. Haddab, LF noise in cross Hall effect devices - geometrical study Proceedings of SPIE - Noise in Devices and Circuits, Santa Fe, New Mexico, USA 2003, ed. M.J. Deen, Z. Celik-Butler, M.E. Levinshtein, SPIE Publishing, 5113 (2003) 475-483 2.V. Mosser, G. Jung, J. Przybytek, M. Ocio, Y. Haddab, Low-frequency noise in AlGaAs/InGaAs/GaAs Hall micromagnetometers - Proceedings of SPIE -